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Bio Data Sheet

CONFIRMATION NO. 8647

SERIAL NUMBER 10/656,130	FILING DATE 09/08/2003 RULE ✓	CLASS 156	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 00839.000419.1
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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

This application is a DIV of 09/261,499 03/03/1999 PAT 6,645,573

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 050321/HEI.10 03/03/1998

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 13	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>M. J. Chandra</i> Initials <i>MS</i>				

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## TITLE

Process for forming a microcrystalline silicon series thin film and apparatus suitable for practicing said process

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